LFW

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Popl. No.

10/624,356

: Confirmation No.:

7682

Applicant

Aaron Scott Lukas et al.

Filed

21 July 2003

For

Non-Thermal Process for Forming Porous Low Dielectric Constant

Films

Art Unit

Sir:

П

1771

Examiner

Victor S. Chang

Docket No.

06336PUSA

Customer No.

23543

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450 CERTIFICATE OF MAILING

I CERTIFY THAT THIS PAPER (ALONG WITH ANY PAPER REFERRED TO AS BEING ATTACHED OR ENCLOSED) IS BEING DEPOSITED WITH THE UNITED STATES POSTAL SERVICE WITH SUFFICIENT POSTAGE AS FIRST CLASS MAIL IN AN ENVELOPE ADDRESSED TO:

COMMISSIONER FOR PATENTS
P.O. BOX 1450

ALEXANDRIA, VA 22313-1450

ON

Date

Rosaleen Morris-Oskanian

(Typa or print name of person mailing paper)

Ko Sul

of this paper and include an

## RESPONSE TO RESTRICTION REQUIREMENT

The following is responsive to the Office Action dated 6/15/2005:

☐ Amendments to the Specification begin on page of this paper.

☐ Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

attached replacement sheet(s).

Amendments to the Abstract are on page of this paper. A clean version of the Abstract is on page of this paper.

Remarks/Arguments begin on page 9 of this paper.

Amendments to the Drawings begin on page